PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1 Stylesheet Version v1.2 EPAS ID: PAT6460086

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
YUTA IMAI	10/01/2020
MASAHIRO SASAJIMA	09/29/2020
YOSHIHIRO TAKAHOKO	09/29/2020

RECEIVING PARTY DATA

Name:	HITACHI HIGH-TECH CORPORATION	
Street Address:	Street Address: 17-1, TORANOMON 1-CHOME	
City:	MINATO-KU, TOKYO	
State/Country:	JAPAN	

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	17056285

CORRESPONDENCE DATA

Fax Number: (202)628-8844

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using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.

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Correspondent Name: CROWELL & MORING LLP

Address Line 1: P.O. BOX 14300

Address Line 4: WASHINGTON, D.C. 20044

ATTORNEY DOCKET NUMBER:	118262.PD907US
NAME OF SUBMITTER:	MICHAEL H. JACOBS
SIGNATURE:	/Michael H. Jacobs/
DATE SIGNED:	12/19/2020

Total Attachments: 3

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PATENT 506413329 REEL: 054702 FRAME: 0231

ASSIGNMENT

(譲渡証)

As a below named inventor, I hereby declare that:

IN CONSIDERATION of the sum of One Dollar (\$1.00) or the equivalent thereof, and other good and valuable consideration paid to me citizen of Japan by Hitachi High-Tech Corporation, a corporation organized under the laws of Japan, located at 17-1, Toranomon 1-cheme, Minato-ku, Tokyo, Japan, receipt of which is hereby acknowledged I do hereby sell and assign to said Hitachi High-Tech Corporation, its successors and assigns, all my right, title and interest, in and for the United States of America, in and to

CHARGED PARTICLE BEAM DEVICE AND METHOD FOR ADJUSTING POSITION OF DETECTOR
OF CHARGED PARTICLE BEAM DEVICE

invented by me (if only one is named below) or us (if plural inventors are named below) and described in the application for United States Letters Patent therefor, executed on even date herewith, and all United States Letters Patent which may be granted therefor, and all divisions, continuations and extensions thereof, the said interest being the entire ownership of the said Letters Patent when granted, to be held and enjoyed by said Hitachi High-Tech Corporation, its successors, assigns or other legal representatives, to the full end of term for which said Letters Patent may be granted, as fully and entirely as the same would have been held and enjoyed by me or us if this assignment and sale had not been made;

And I hereby agree to sign and execute any further documents or instruments which may be necessary, lawful, and proper in the prosecution of the above-named application or in the proparation and prosecution of any continuing, continuation-in-part, substitute, divisional, renewal, reviewed or release applications or in any amendment, extension, or interference proceedings, or otherwise to secure the title thereto in said assignee;

And I do hereby authorize and request the Commissioner of Patents to issue said Letters Patent to said Hitachi High-Tech Corporation,

Signed on the date(s) indicated aside signatures:

	(発明者フルネームサイン)	(数数1)
1)	Yuta Imai	lo / 1 / 2020
2)	Mesahiro SASAJiMA	
3)	Yeshihiro TAKAHOKO	
4)		
5)		
6)		
7)		
8)		
9)		
0)		

PATENT REEL: 054702 FRAME: 0232

ASSIGNMENT (譲渡証)

As a below named inventor, I hereby declare that:

IN CONSIDERATION of the sum of One Dollar (\$1.00) or the equivalent thereof, and other good and valuable consideration paid to me citizen of Japan by Hitachi High-Tech Corporation, a corporation organized under the laws of Japan, located at 17-1, Toranomon 1-chome, Minato-ku, Tokyo, Japan, receipt of which is hereby acknowledged if do hereby self and assign to said Hitachi High-Tech Corporation, its successors and assigns, all my right, title and interest, in and for the United States of America, in and to

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And I do hereby authorize and request the Commissioner of Patents to issue said Letters Patent to said Hitachi High-Tech Corporation,

Signed on the date(s) indicated aside signatures:

INVENTOR(S)

(発明者フルネームサイン)

1)	Yuta IMAI		_	
2)	Masahiro SASAJIMA	Masahiro Susajima	_	9/29/2020
3)	Yoshihiro TAKAHOKO		_	
4)				
5)			_	
6)			_	
7)				

PATENT REEL: 054702 FRAME: 0233

Date Signed

(署名目)

ASSIGNMENT

(譲渡証)

As a below named inventor, I hereby declare that:

IN CONSIDERATION of the sum of One Dollar (\$1.00) or the equivalent thereof, and other good and valuable consideration paid to me citizen of Japan by Hitschi High-Tech Corporation, a corporation organized under the laws of Japan, located at 17-1, Toranomon 1-chame, Minato-ku, Tokyo, Japan, receipt of which is hereby acknowledged I do hereby sell and assign to said Hitachi High-Tech Corporation, its successors and assigns, all my right, little and interest, in and for the United States of America, in and to

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OF CHARGED PARTICLE BEAM DEVICE

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And I hereby agree to sign and execute any further documents or instruments which may be necessary, lawful, and proper in the prosecution of the above-named application or in the preparation and prosecution of any continuing, continuation-in-part, substitute, divisional, renewal, reviewed or reissue applications or in any amendment, extension, or interference proceedings, or otherwise to secure the title thereto in said assignee;

And I do hereby authorize and request the Commissioner of Patents to issue said Letters Patent to said Hitachi High-Tech Corporation,

Signed on the date(s) indicated aside signatures:

Contract of the second con-

	ANVEN: OR(3)	(署名日)
1).	Yuia IMAI	
2)	Masshiro SASAJIMA	
3)	Yoshihiro TAKAHOKO Yoshihiro Takah	oko <u>9/29/2020</u>
4)		
5)		
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PATENT REEL: 054702 FRAME: 0234

RECORDED: 12/19/2020